

**CHE323/384 Chemical Processes for Micro- and Nanofabrication**  
**Chris Mack, University of Texas at Austin**

Homework #1 Solutions

1. For dopant atoms uniformly distributed in a silicon crystal, how far apart are these dopant atoms when the doping concentration is a)  $2 \times 10^{15} \text{ cm}^{-3}$ , b)  $10^{18} \text{ cm}^{-3}$ , c)  $7 \times 10^{20} \text{ cm}^{-3}$ .

The average distance between dopant atoms is the cubed root of the concentration. Thus,

- a)  $d = (2 \times 10^{15} \text{ cm}^{-3})^{-1/3} = 0.794 \times 10^{-5} \text{ cm} \approx 80 \text{ nm}$  (keeping one digit of precision)  
b)  $d = (1 \times 10^{18} \text{ cm}^{-3})^{-1/3} = 1 \times 10^{-6} \text{ cm} = 10 \text{ nm}$   
c)  $d = (7 \times 10^{20} \text{ cm}^{-3})^{-1/3} = 1.13 \times 10^{-7} \text{ cm} \approx 1.1 \text{ nm}$

2. What is the resistivity of pure silicon at room temperature?

$$\frac{1}{\rho} = \sigma = q(n\mu_n + p\mu_p), \quad n = p = n_i$$

$$\sigma = 1.6 \times 10^{-19} \text{ C} (1.5 \times 10^{10} \text{ cm}^{-3}) \left( 1500 \frac{\text{cm}^2}{\text{Vs}} + 450 \frac{\text{cm}^2}{\text{Vs}} \right) = 4.7 \times 10^{-6} (\Omega \text{cm})^{-1}$$

$$\rho = 2.1 \times 10^5 \Omega \text{cm}$$

(Note that silicon dioxide has a resistivity of about  $10^{14} \Omega \text{cm}$ , and copper is about  $10^{-6} \Omega \text{cm}$ .)

3. a) Show that the minimum conductivity of a semiconductor occurs when  $n = n_i \sqrt{\mu_p / \mu_n}$ .

Use the mass action equation  $np = n_i^2$  to put  $p$  in terms of  $n$  in the conductivity equation.

$$\sigma = q \left( n\mu_n + \frac{n_i^2}{n} \mu_p \right)$$

Now take the derivative wrt  $n$ , set it equal to zero, and solve for  $n$ .

$$\frac{d\sigma}{dn} = q \left( \mu_n - \frac{n_i^2}{n^2} \mu_p \right) = 0, \quad n^2 = n_i^2 \frac{\mu_p}{\mu_n}, \quad n = n_i \sqrt{\frac{\mu_p}{\mu_n}}$$

3. b) How does the minimum conductivity for silicon compare to the intrinsic conductivity of silicon at room temperature?

Using the results of 3a in the equation for the conductivity,  $\sigma_{min} = 2qn_i\sqrt{\mu_n\mu_p}$ .

$$\sigma = 2(1.6 \times 10^{-19}C)(1.5 \times 10^{10}cm^{-3}) \sqrt{\left(1500 \frac{cm^2}{Vs}\right)\left(450 \frac{cm^2}{Vs}\right)} = 3.9 \times 10^{-6}(\Omega cm)^{-1}$$

This is only a little smaller (16%) than the value for intrinsic silicon calculated in problem 2.

4. Consider a resistor made of pure silicon with a cross-sectional area of  $0.5 \mu m^2$ , and a length of  $50 \mu m$ . What is the resistance of this silicon piece? For an applied voltage of 5 V, how much current would flow through it?

$$R = \rho \frac{L}{A} = 2.1 \times 10^5 \Omega cm \frac{50 \mu m}{0.5 \mu m^2} \left( \frac{10,000 \mu m}{1 cm} \right) = 2.1 \times 10^{11} \Omega$$

(That's a big resistance!)

$$V = IR, \quad I = \frac{5V}{2.1 \times 10^{11} \Omega} = 24 \text{ pA}$$

5. Suppose the resistor of problem 4 were made of p-type silicon. What doping level would be required to make the resistance equal to  $25 \text{ k}\Omega$ ?  $25 \Omega$ ?

The required conductivity is  $\sigma = \frac{1}{\rho} = \frac{1}{R} \frac{L}{A} = \frac{1}{25,000} \frac{50 \mu m}{0.5 \mu m^2} \left( \frac{10,000 \mu m}{1 cm} \right) = 40(\Omega cm)^{-1}$

For p-type silicon, the electron concentration can be ignored and the conductivity will be

$$\sigma = qp\mu_p = qN_A\mu_p \text{ (since } p \approx N_A\text{). Thus,}$$

$$N_A = \frac{\sigma}{q\mu_p} = \frac{40(\Omega cm)^{-1}}{(1.6 \times 10^{-19}C)\left(450 \frac{cm^2}{Vs}\right)} = 5.6 \times 10^{17} cm^{-3}$$

To make a  $25 \Omega$  resistor, the doping level would have to be 1000 times higher:  $5.6 \times 10^{20} cm^{-3}$ . This can be hard to do, since it is near the solid solubility limit for most dopants.